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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/568,683	02/17/2006	Sumi Tanaka	33082M301	2808
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1130 CONNECTICUT AVENUE, N.W., SUITE 1130 WASHINGTON, DC 20036			KACKAR, RAM N	
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			1792	
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Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Application No.	Applicant(s)				
	10/568,683	TANAKA ET AL.				
Office Action Summary	Examiner	Art Unit				
	Ram N. Kackar	1792				
The MAILING DATE of this communication ap	ppears on the cover sheet w	ith the correspondence address				
• •	VIC SET TO EVOIDE 2 M	MONITH(E) OR THIRTY (30) DAVE				
A SHORTENED STATUTORY PERIOD FOR REPL WHICHEVER IS LONGER, FROM THE MAILING I - Extensions of time may be available under the provisions of 37 CFR 1. after SIX (6) MONTHS from the mailing date of this communication. If NO period for reply is specified above, the maximum statutory period Failure to reply within the set or extended period for reply will, by statu Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNI .136(a). In no event, however, may a d will apply and will expire SIX (6) MON te, cause the application to become AB	CATION. reply be timely filed NTHS from the mailing date of this communication. BANDONED (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on 25 (October 2007.					
2a) ☑ This action is FINAL . 2b) ☐ Thi	This action is FINAL. 2b) This action is non-final.					
,	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the practice under	Ex parte Quayle, 1935 C.L	D. 11, 453 O.G. 213.				
Disposition of Claims						
4)⊠ Claim(s) <u>1-4 and 6-11</u> is/are pending in the a	☑ Claim(s) <u>1-4 and 6-11</u> is/are pending in the application.					
	4a) Of the above claim(s) <u>10 and 11</u> is/are withdrawn from consideration.					
5) Claim(s) is/are allowed.						
6) Claim(s) 1-4 and 6-9 is/are rejected.						
(7) ☐ Claim(s) is/are objected to.8) ☐ Claim(s) are subject to restriction and/	or election requirement					
Application Papers		•				
9) The specification is objected to by the Examin		h. the E. certain				
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner. Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the corre	* '					
11) The oath or declaration is objected to by the E	•					
Priority under 35 U.S.C. § 119						
12)⊠ Acknowledgment is made of a claim for foreig a)⊠ All b)□ Some * c)□ None of:	n priority under 35 U.S.C.	§ 119(a)-(d) or (f).				
1.⊠ Certified copies of the priority documer						
2. Certified copies of the priority documer	2. Certified copies of the priority documents have been received in Application No					
3. Copies of the certified copies of the pri	•	received in this National Stage				
application from the International Bures		and the second				
* See the attached detailed Office action for a lis	a of the certified copies not	received.				
Attachment(s)	A) 🗖 1-4	Summany (PTO 412)				
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(Summary (PTO-413) (s)/Mail Date				
3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	5) Notice of 6) Other:	Informal Patent Application				

10/568,683 Art Unit: 1792

DETAILED ACTION

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 1. Claims 1-3, 8 and 9 are rejected under 35 U.S.C. 103(a) as being unpatentable over to Yoshida (JP 2000021957) in view of Hanamachi et al (US 7241346).

Yoshida teaches a support column provided at a top end portion thereof with a flanged part, and a substrate holding table joined to the flanged part, wherein: the substrate holding table includes a heating mechanism; the substrate holding table is provided in a lower surface thereof with a U-shaped groove extending along an outer circumferential surface of the flanged part; and an inner circumferential surface of the U-shaped groove is connected to the outer circumferential surface of the flanged parts to form a continuous single plane. (See, for example, Fig. 1).

Yoshida teaches a groove formed in a part of a portion, opposing the flanged part, of the lower surface of the substrate holding table (See, for example, Fig. 4, 6) and the flanged part joined to the lower surface of the substrate holding table only at an outermost annular area thereof but does not show second groove separation from the upper surface of the remaining part of the flange.

Application/Control Number:

10/568,683 Art Unit: 1792

This groove is however to reduce the contact area between the flange part and the substrate holding part.

Hanamachi et al discloses a contact part between a substrate holding part and a flange so as to provide a separation of remaining area from the substrate holding part which is radially inside as well as outside as claimed in order to reduce area of contact (Fig 1, 2 and 5-7).

Therefore it would have been obvious for one of ordinary skill in the art at the time of invention to have a separation in order to reduce area of contact to reduce heat transfer.

Regarding claim 2, Yoshida teaches both an end portion of a profile line of the inner circumferential surface of the U-shaped groove on a side of the flanged part and a profile line of the outer circumferential surface of the flanged part are situated on a single line segment extending in a vertical direction. (See, for example, Fig. 1).

For claim 3, Yoshida teaches the substrate holding structure is made by joining the flanged part and the substrate holding table to each other after forming them individually. (See, for example, Fig. 1).

Regarding claim 8, Yoshida teaches the substrate holding table and the support column are made of ceramics. (See, for example, para [0017]).

For claim 9, Yoshida teaches a processing vessel connected to an exhaust system, a gas supply system that supplies a process gas into the processing vessel; and the substrate holding structure, as defined in claim 1, arranged in the processing vessel. (See, for example, Fig. 1).

10/568,683 Art Unit: 1792

2. Claim 4 is rejected under 35 U.S.C. 103(a) as being unpatentable over Yoshida (JP 2000021957) in view of Hanamachi et al (US 7241346) as applied to claims 1-3, 5, 8 and 9 and further view of JP 2004-022382 to Goto et al.

Yoshida does not teach that an inner circumferential surface of the flanged part provides an inclined surface.

Goto teaches that an inner circumferential surface of the flanged part provides an inclined surface, which is inclined such that an inner diameter of the flanged part successively increases as approaching the lower surface of the substrate holding table. (See, for example, Fig. 1).

At the time of the invention, it would have been obvious to a person of ordinary skill in the art to incline the inner circumferential surface of the flanged part in Yoshida.

The suggestion/motivation would have been to reduce thermal stress. (Goto, Abstract).

3. Claim 6 is rejected under 35 U.S.C. 103(a) as being unpatentable over Yoshida (JP 2000021957) in view of Hanamachi et al (US 7241346) as applied to claims 1-3, 5, 8 and 9 and further in view of Watanabe et al (JP 11-354526).

Yoshida does not teach inner and outer heating-mechanism parts driven by first and second drive power supply system both extending in the support column, respectively.

Watanabe teaches an inner heating-mechanism part 9b and an outer heating-mechanism part 9a formed outside the inner heating-mechanism part; and the inner heating-mechanism part and the outer heating-mechanism part are driven by first and second drive power supply system both extending in the support column, respectively. (See, for example, Fig. 1, 2).

Application/Control Number:

10/568,683 Art Unit: 1792

At the time of the invention, it would have been obvious to a person of ordinary skill in the art to divide the heater of Yoshida into inner and outer heating mechanism parts.

The suggestion/motivation would have been to increase temperature control. (Watanabe, Abstract).

4. Claim 7 is rejected under 35 U.S.C. 103(a) as being unpatentable over Yoshida (JP 2000021957) in view of Hanamachi et al (US 7241346) and Watanabe et al (JP 11-354526) as applied to claim 6 and further in view of US 6,215,643 to Nagasaki ("Nagasaki").

Neither Yoshida nor Watanabe teaches first and second semicircular conductive patterns.

Nagasaki teaches first and second semicircular conductive patterns 4 connected to first and second power supply lines 6; and the first and second conductive patterns substantially cover whole area of the substrate holding table except for gap areas defined between the first conductive pattern and the second conductive pattern. (See, for example, Fig. 1B, 2A).

At the time of the invention, it would have been obvious to a person of ordinary skill in the art to utilize semicircular conductive patterns with the teachings of Yoshida and Watanabe

The suggestion/motivation would have been because electrostatic chucks are conventionally employed for holding substrates. (Nagasaki, col. 1, lines 19-26).

None of these references specifically teaches the conductive patterns arranged below the heating mechanism. However, this configuration is merely a rearrangement of parts that is obvious in view of the prior art. See *In re Japikse*, 181 F.2d 1019, 86 USPQ 70 (CCPA 1950). The ability to of the conductive pattern to chuck the substrate actually decreases as the distance increases between the top of the holding structure and the conductive pattern. Hence, the

Application/Control Number:

10/568,683 Art Unit: 1792

placement of the conductive pattern below the mechanism would actually be deleterious and obvious as compared to the configuration in Nagasaki.

Further, these references do not teach the conductive patterns and heating mechanisms connected to the first and second power supply lines. It would have been obvious to do so because this configuration merely integrates the power supply lines that connect to the respective heater mechanisms and conductive patterns.

Response to Arguments

Applicant's arguments filed 10/25/2007 have been fully considered but they are not persuasive.

Applicant's arguments regarding drawings, claim objections and Sec 112 rejection have persuaded their removal. Applicants other arguments in favor of amendments are not persuasive in view of the recent rejection.

Conclusion

1. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period

10/568,683

Art Unit: 1792

will expire on the date the advisory action is mailed, and any extension fee pursuant to 37

CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event,

however, will the statutory period for reply expire later than SIX MONTHS from the date of this

final action. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Ram N. Kackar whose telephone number is 571 272 1436. The

examiner can normally be reached on M-F 8:00 A.M to 5:P.M.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Parviz Hassanzadeh can be reached on 571 272 1435. The fax phone number for the

organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent

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Ram Kackar

Primary Examiner AU1792